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PATENT

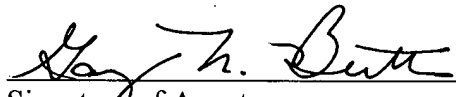
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Holger Heuermann
Serial No. : 10/810,417 Examiner : Mary C. Baran
Filed : March 26, 2004 Group Art Unit : 2857
For : CALIBRATION METHOD FOR CARRYING OUT MULTIPORT
MEASUREMENTS ON SEMICONDUCTOR WAFERS

RESPONSE

I hereby certify that this paper is being deposited on **December 14, 2005** with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendments, Commissioner for Patents, Alexandria, VA 22313-1450.

Gary M. Butter 33,841
Agent for Applicant PTO Reg. No.

 December 14, 2005
Signature of Agent Date of Signature

Mail Stop **Amendments**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This responds to the Office Action dated June 29, 2005 received from the United States Patent and Trademark Office in connection with the above-identified patent application. Applicant encloses herewith a petition for a three (3)-month extension of time to file this response and a check for \$1020 in payment of the required fee under 37 C.F.R. §1.17(a)(3).

Please amend the above-identified application as follows:

Amendments to the Specification begins on page 3 of this paper.

Amendments to the Claims begins on page 4 of this paper.

Remarks begins on page 9 of this paper.